## Lecture 7w: Process Modules III

## Lecture 7: Process Modules III

- · Announcements:
- This is another 2 hour lecture last one to make up for the missed lecture
- · HW#2 online; due Tuesday, Sept. 25
  - ⋄ A new version was uploaded recently, on which problem 1(b) was rephrased
- The BSAC IAB is happening this Thursday, but I can still do the lecture, so we will still have lecture
- . -----
- · Today:
- · Reading: Senturia, Chpt. 3; Jaeger, Chpt. 2, 4, 5
  - **United States** Lithography
  - **Setching** 
    - -Wet etching
    - -Dry etching
  - \$ Semiconductor Doping
    - -Ion implantation
    - -Diffusion
- -----
- · Last Time:
- $\bullet$  Going through Module 4 ... continue with this today